



PATENT  
Attorney Docket No.: SSI-04001

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

William Dale Jones

Serial No.: 10/680,783

Filed: October 6, 2003

For: **HIGH-PRESSURE PROCESSING  
CHAMBER FOR A  
SEMICONDUCTOR WAFER**

} Group Art Unit: 1763  
} Examiner: Lund, Jeffrie Robert  
} Response to the final Office Action mailed  
} on January 30, 2006  
} 162 N. Wolfe Road  
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*Entered the  
With 06  
4-25-06  
JPC*  
Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

The Applicant submits this response to the final Office Action mailed on January 30, 2006:

**Amendments to the Claims** are reflected in the listing of claims, which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 6 of this paper.